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	Application No.	Applicant(s)
Notice of Allowability	10/766,014	HAIDNER ET AL.
	Examiner	Art Unit
	Andrew Hwa S. Lee	2886
The MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS nerewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this ap or other appropriate communicatior GHTS. This application is subject t	plication. If not included not will be mailed in due course. THIS
1. This communication is responsive to 7/23/07.	•	
2. The allowed claim(s) is/are <u>10-23</u> .		
3. ☐ Acknowledgment is made of a claim for foreign priority un a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).	been received. been received in Application No	
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give		
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) 🔲 including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached		
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	Office action of
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the		
 DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT 		
φ		
Attachment(s) 1. ⊠ Notice of References Cited (PTO-892)	5. Notice of Informal F	Patent Application
2. ☐ Notice of Aerercices Cited (F10-092) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary	• •
3. ☐ Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Da 7. ☐ Examiner's Amend	ite
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	_	ent of Reasons for Allowance
of Biological Material	9. Other	
	J	/200/
	2	Andrew Hwa S. Lee Primary Examiner Art Unit: 2886

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REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance: The prior art of record fails to show or to suggest a method for optical measurement of an optical system comprising of all the steps as presently claimed where a distortion error is determined by determining a distortion function from a comparison of detected actual positions of interference fringes with computational desired positions when changing one or more external parameters, the change in the at least one external parameter comprising at least one of a change in the position of a detector arrangement or of a mask structure of a measuring device parallel to a main optical axis, a change in the wavelength of the measuring radiation, and a change in aberrations through adjustment of xy-manipulators or z-manipulators of the measured optical system.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrew Hwa S. Lee whose telephone number is 571-272-2419. The examiner can normally be reached on Tue-Fr.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tarifur R. Chowdhury can be reached on 571-272-2800. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Andrew Hwa S. Lee Primary Examiner Art Unit 2886